

31040 U.S. PTO
 10/084848
 02/25/02

PATENT NUMBER and
 ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10084848	FILING DATE 02/25/2002	CLASS 438	SUBCLASS	GAU 2812	EXAMINER DOWNS
**APPLICANTS: Kido Shusaku;					
**CONTINUING DATA VERIFIED:					
<p>BEST AVAILABLE COPY</p>					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 58138/2001 03/02/2001					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no				ATTORNEY DOCKET NO	
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no				MEC IPS-2364	
Verified and Acknowledged Examiners's initials					
TITLE : Process for forming pattern and method for producing liquid crystal apparatus employing process for forming pattern					
<small>U.S. DEPT. OF COMM. / PAT. & TM-PTO-436L (Rev. 12-94)</small>					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for 0.6
Assistant Examiner		DRAWING	
ISSUE FEE		Sheets Drwg.	Figs. Drwg.
Amount Due	Date Paid	Print Fig.	
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH: DISK (CRF) CD-ROM
 (Attached in pocket on right inside flap)